

| INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i> | | | | Docket Number (Optional) 08850001AA | | Application Number 10/774,693 | |
|---|-----|--|---------|---|-------------------------------|---|----------------------------|
| | | | | Applicant(s) Katsap | | | |
| | | | | Filing Date 2-10-04 | Group Art Unit 2879 | | |
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| EXAMINER /Joseph Williams/ (05/23/2006) | | | | DATE CONSIDERED | | 05/23/2006 | |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | | | |